



## C. Material Growth & Characterization 분과

2021년 1월 28일(목), 09:00-10:30 / 채널 B

### [TB1-C] Wide Bandgap Materials I

좌장: 김지현 교수 (고려대학교), 이신범 교수 (DGIST)

<p><b>TB1-C-1</b> 09:00-09:30</p>	<p><b>[초청]</b> <b>Bulk-Rashba Effect in the Non-Centrosymmetric Artificial Superlattice</b> Sanghoon Kim <i>Department of Physics, University of Ulsan</i></p>
<p><b>TB1-C-2</b> 09:30-09:45</p>	<p><b>Diamond Schottky Barrier Diode Grown on Sapphire-based Freestanding Heteroepitaxial Diamond Substrate Using Microwave Plasma Chemical Vapor Deposition</b> Taemyung Kwak<sup>1</sup>, Uiho Choi<sup>1</sup>, Jonggun Lee<sup>1</sup>, Sanghun Han<sup>1</sup>, Geunho Yoo<sup>1</sup>, Seong-woo Kim<sup>2</sup>, and Okhyun Nam<sup>1</sup> <sup>1</sup><i>Department of Nano &amp; Semiconductor Engineering, Korea Polytechnic University,</i> <sup>2</sup><i>Namiki Precision Jewel Co., Ltd.</i></p>
<p><b>TB1-C-3</b> 09:45-10:00</p>	<p><b>Boron-doped Diamond Metal-semiconductor Field-effect Transistor Grown on Heteroepitaxial Diamond Substrate</b> Uiho Choi<sup>1</sup>, Taemyung Kwak<sup>1</sup>, Jonggun Lee<sup>1</sup>, Sanghun Han<sup>1</sup>, Geunho Yoo<sup>1</sup>, Seongwoo Kim<sup>2</sup>, and Okhyun Nam<sup>1</sup> <sup>1</sup><i>Convergence Center for Advanced Nano Semiconductor, Department of Nano &amp; Semiconductor Engineering, Korea Polytechnic University,</i> <sup>2</sup><i>Adamant Namiki Precision Jewel Co., Ltd.</i></p>
<p><b>TB1-C-4</b> 10:00-10:15</p>	<p><b>Effect of Doping on the Threading Dislocation Density of GaAs Layer Epitaxially Grown on Si</b> Geunhwan Ryu<sup>1</sup>, Seungwan Woo<sup>1,2</sup>, Rafael Chu<sup>1</sup>, In-Hwan Lee<sup>2</sup>, Daehwan Jung<sup>1</sup>, and Won Jun Choi<sup>1</sup> <sup>1</sup><i>Center for Opto-electronic Materials and Devices, KIST,</i> <sup>2</sup><i>Department of Materials Science and Engineering, Korea University</i></p>
<p><b>TB1-C-5</b> 10:15-10:30</p>	<p><b>Ab initio Approach on the Anisotropic Growth of GaAs: from DFT to Growth Kinetics</b> In Won Yeu<sup>1</sup>, Gyuseung Han<sup>1,2,3</sup>, Cheol Seong Hwang<sup>2,3</sup>, and Jung-Hae Choi<sup>1</sup> <sup>1</sup><i>Electronic Materials Research Center, KIST,</i> <sup>2</sup><i>Department of Materials Science and Engineering, Seoul National University,</i> <sup>3</sup><i>Inter-University Semiconductor Research Center, Seoul National University</i></p>